

Attorney's Docket No.: 05542-552001 / 8402/C

IN THE LINITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chen et al.

Art Unit : Unknown Examiner: Unknown

Serial No.: 10/732,966 Filed

: December 10, 2003

Title : RETAINING RING WITH SLURRY TRANSPORT GROOVES

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. No fee is believed to be due. If, however, there are any charges or credits, please apply them to Deposit Account No. 06-1050. Respectfully submitted,

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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SEP 0-7 20

Substitute Form PTO-1449 (Modified) U.S. Department of Commerce Patent and Trademark Office Attorney's Docket No. Application No. 05542-552001 10/732,966

Information Disclosure Statement by Applicant (Use several sheets if necessary) Applicant
Chen et al.
Filing Date

December 10, 2003

Group Art Unit

Unknown

(37 CFR §1.98(b))

			U.S. Pate	ent Documents			
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,205,082	04/27/93	Shendon et al.			
	AB	5,423,558	06/13/95	Koeth et al.			
	AC	5,584,751	12/17/96	Kobayashi et al.			
-	AD	5,605,487	02/25/87	Hileman et al.			
	AE	5,605,488	02/25/97	Ohashi et al.			
	AF	5,635,083	06/03/97	Breivogel et al.			
	AG	5,643,053	07/01/97	Shendon			
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	AK	5,664,988	09/09/97	Stroupe et al.			
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	AO	5,851,140	12/22/98	Barns et al.			
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	AS	6,251,215	06/26/01	Zuniga et al.			
-	AT	6,277,008	08/21/01	Masuta et al.			

Foreign Patent Documents or Published Foreign Patent Applications									
Examiner	Desig.	Document	Publication	Country or			Trans	Translati o n	
Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No	
	AU	0 988 931 A2	03/29/00	EPO	1				
	AV	0 790 100 A1	08/20/97	EPO					
	AW	0 841 123 A1	05/13/98	EPO					
	AX	0 776 730 A	06/04/97	EPO					

Examiner Signature

/Sylvia Macarthur/

Date Considered 08/28/2009

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Substitute Disclosure Form (PTO-1449)

Substitute Form PTO-1449 U.S. Department of Commerce (Modified) Patent and Trademark Office				
	closure Statement	Applicant Chen et al.		
(Use several sheets if necessary) (37 CFR §1.98(b))		Filing Date December 10, 2003	Group Art Unit Unknown	

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Trans Yes	No
	AY	2 336 121 A	10/13/99	Great Britain				

Other Documents (include Author, Title, Date, and Place of Publication)					
Examiner	Desig.	Denimont			
Initial	ID	Document			
	AZ	"SPM's PPS Ring Sales History", January 1997 thru November 1999			
-	AAA	Yuan, et al., A novel Wafer Carrier Ring Design Minimizes Edge Over-Polishing Effects for Chemical Mechanical Polishing, June 27-29 1995 VMIC Conference, 1995 ISMIC 104/95/525, pp. 525-527.			

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /SM/

/Sylvia Macarthur/	08/28/2009
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